



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Basol et al. Serial No.: 10/761,877 Filed: January 21, 2004 Title: Chemical Mechanical Polishing Method And Apparatus For Controlling Material Removal Profile	Group Art Unit: 3723 Examiner: Not yet assigned Docket: NT-316-US
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INFORMATION DISCLOSURE STATEMENT

US PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
<i>AA</i>	AA	6,712,679	Mar., 30, 2004	Taylor et al.	Copy Enclosed

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		

OTHER DOCUMENTS

Examiner Initials	Cite No.			Trans- lation

Examiner Signature	<i>AA</i>	Date Considered	11/29/05
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